



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 22, 2024
IGI Report Number **LG659412601**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **CUT CORNERED RECTANGULAR MODIFIED BRILLIANT**
Measurements **7.77 X 5.49 X 3.72 MM**

GRADING RESULTS

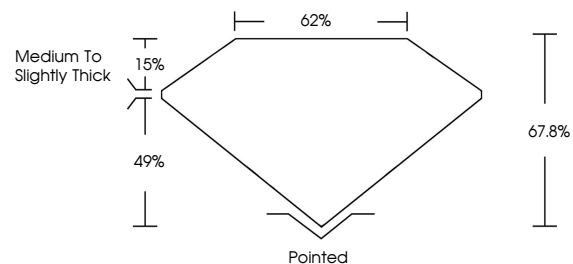
Carat Weight **1.43 CARAT**
Color Grade **E**
Clarity Grade **VVS 2**
Cut Grade **EXCELLENT**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG659412601**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

COLOR

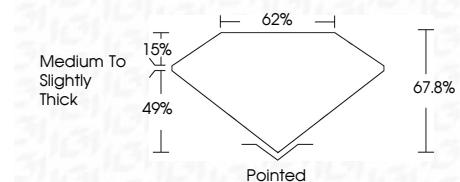
D E F G H I J Faint Very Light Light

CLARITY

| | | | | |
|---------------------|-----------------------------|------------------------|-------------------|------------------|
| IF | VS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
| Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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IGI



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CUT CORNERED RECT. MODIFIED BRILLIANT
7.77 X 5.49 X 3.72 MM
Carat Weight **1.43 CARAT**
Color Grade **E**
Clarity Grade **VVS 2**
Cut Grade **EXCELLENT**
Depth **67.8%**
Table **62%**
Girdle **Medium To Slightly Thick**
Culet **Pointed**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
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